

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner:

Group Art Unit: 1762

B. Talbot

Serial No.

09/903,114

Filed:

July 11, 2001

For:

THERMAL PROCESSING SYSTEM

AND METHODS FOR FORMING

LOW-K DIELECTRIC FILMS

SUITABLE FOR INCORPORATION

INTO MICROELECTRONIC DEVICES

Docket No.

FSI0006/US/2

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 1 CERTIFY THAT ON 30, 2003, THIS PAPER IS BEING DEPOSITED WITH THE U.S. POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO THE COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450

Introductory Comments

SUBMISSION UNDER 37 C.F.R. § 1.114

Dear Sir or Madam:

This Submission is being filed concurrently with a Request for Continued Examination under 37 C.F.R. § 1.114 and is fully responsive to the Final Office Action, mailed January 30, 2003, in the above-mentioned application.

Request for Extension of Time

The three-month shortened statutory period for response to the Final Office Action in the above-mentioned application expired on April 30, 2003. Pursuant to 37 CFR 1.136, Applicants hereby request a two-month extension of time to file this Submission and concurrently filed Request for Continued Examination, extending the date for response to June 30, 2003. The fee of \$ 410.00 for the extension of time is enclosed herewith.

The fee of \$ 750.00 for the Request for Continued Examination is enclosed herewith.

It is believed that no additional fee is required in filing this Submission and concurrently filed Request for Continued Examination. However, the Commissioner is authorized to charge any additional fees or credit any overpayment to Kagan Binder Deposit Account No. 50-1775 and notify the undersigned of the same.

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